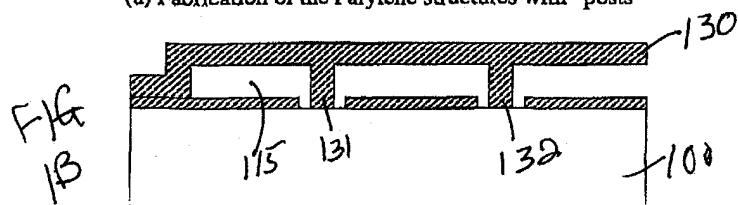
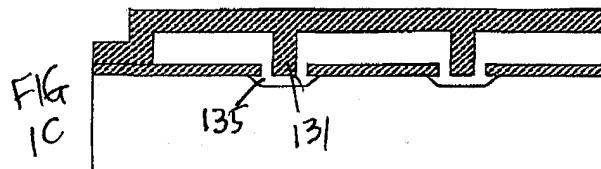


(a) Fabrication of the Parylene structures with "posts"



(b) Dissolution of photoresist in acetone



(c) Free the structures with gas phase silicon etching

Figure 3 Anti-stiction technology with "posts"

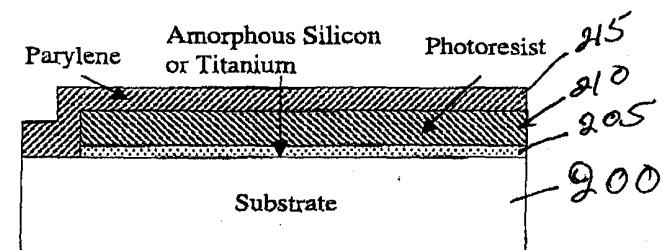


FIG
8A
(a) Fabrication of the Parylene structures with composite sacrificial layer

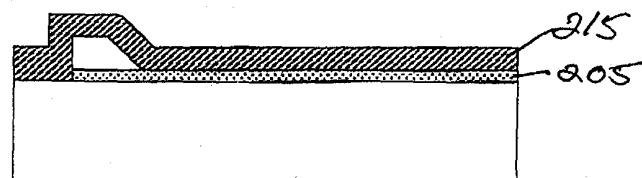


FIG
8B
(b) Dissolution of photoresist in acetone

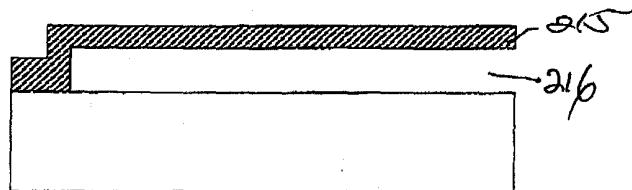
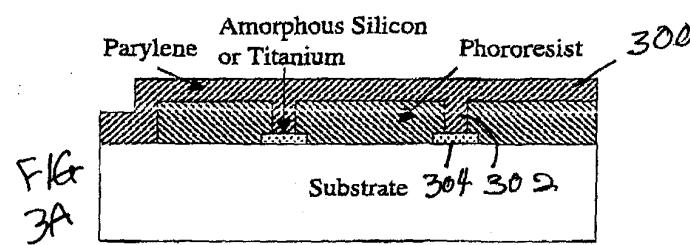


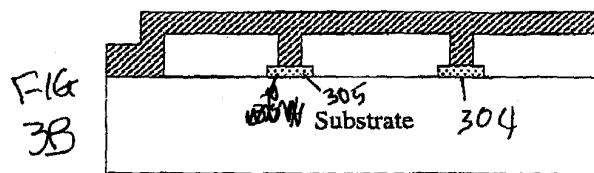
FIG
8C
(c) Free the structures with gas phase etching

Figure 4 Anti-stiction technology with composite sacrificial layer

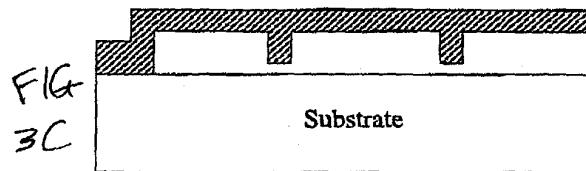
TOP SECRET//EYES ONLY



(a) Fabrication of the Parylene structures with "posts"



(b) Dissolution of photoresist in acetone



(c) Free the structures with gas phase etching

Figure 3 Anti-stiction technology with "posts" and composite sacrificial layer